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Date: July 7, 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

: Wolfgang Rösner et al.

Applic. No.

: 10/047,013

Filed

: January 16, 2002

Title

: Method for Producing a Vertical Semiconductor

Transistor Component and Vertical Semiconductor Transistor Component

Examiner

: Fazli Erdem

Group Art Unit: 2826

ECHNOLOGY CENTER 2800

RESPONSE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Responsive to the Office action dated April 14, 2003 the following remarks are made: